



1/7

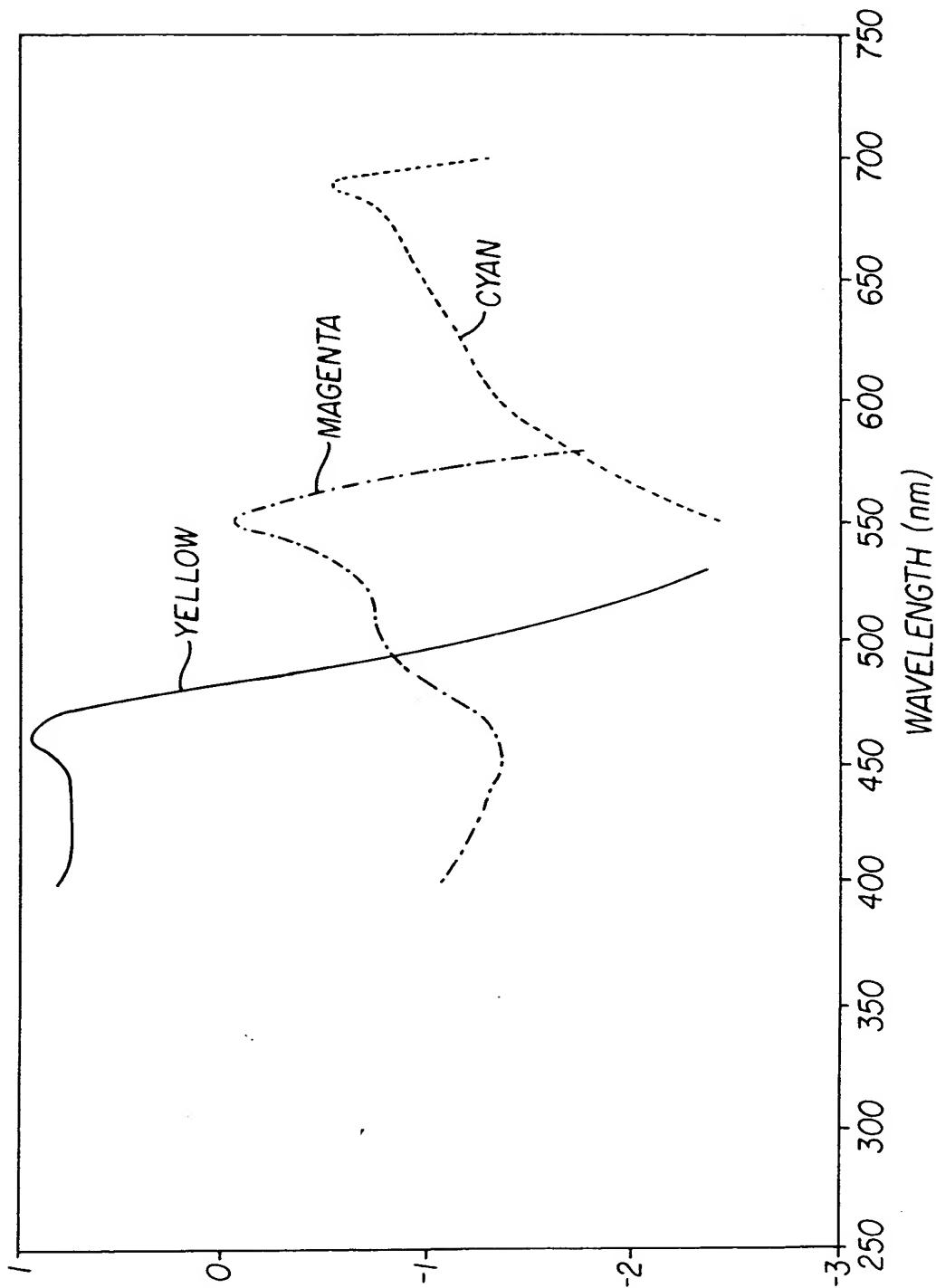


FIG. 1

LOG SENSITIVITY
(SENSITIVITY = RECIPROCAL OF EXPOSURE (ERGS/SQ CM)
REQUIRED TO PRODUCE SPECIFIED DENSITY)

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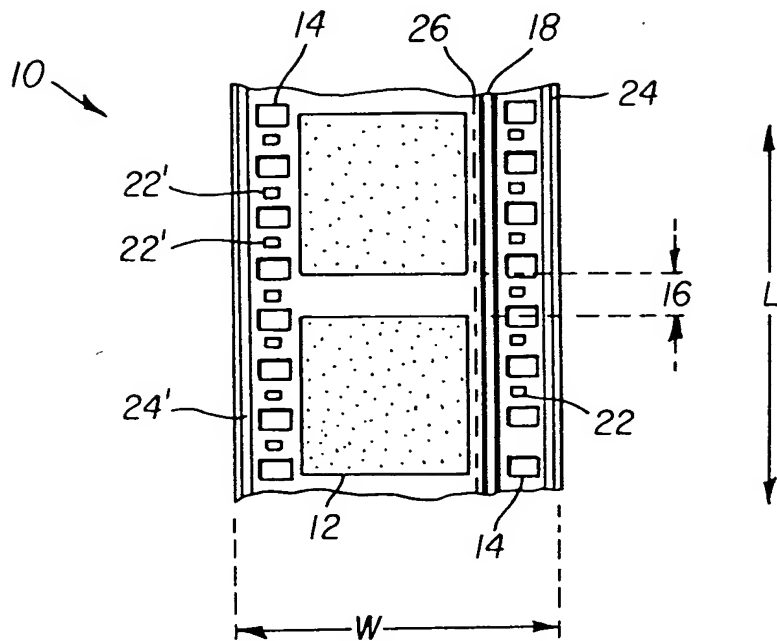


FIG. 2
(Prior Art)

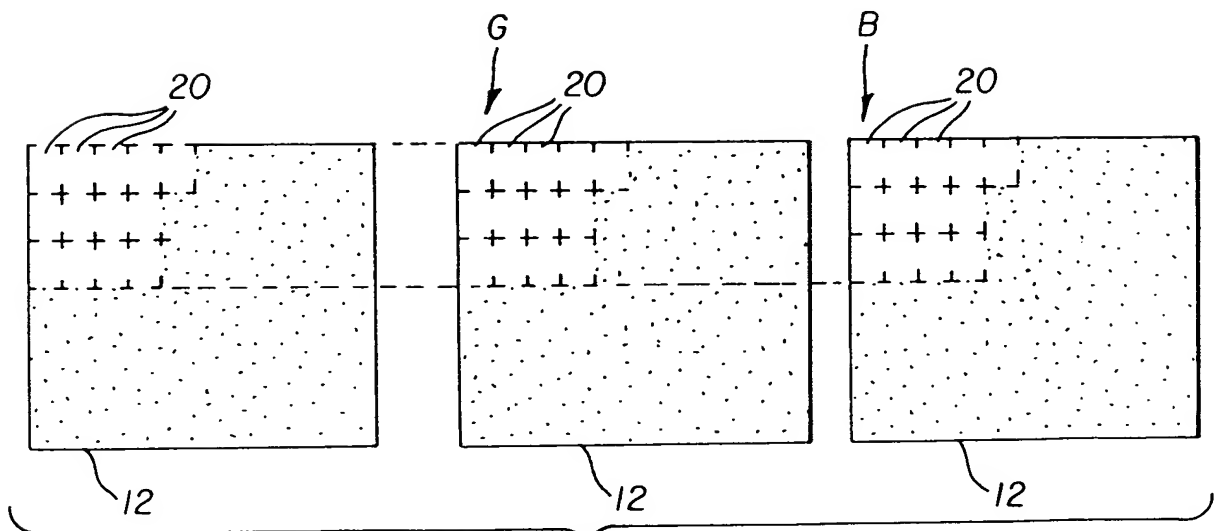


FIG. 3

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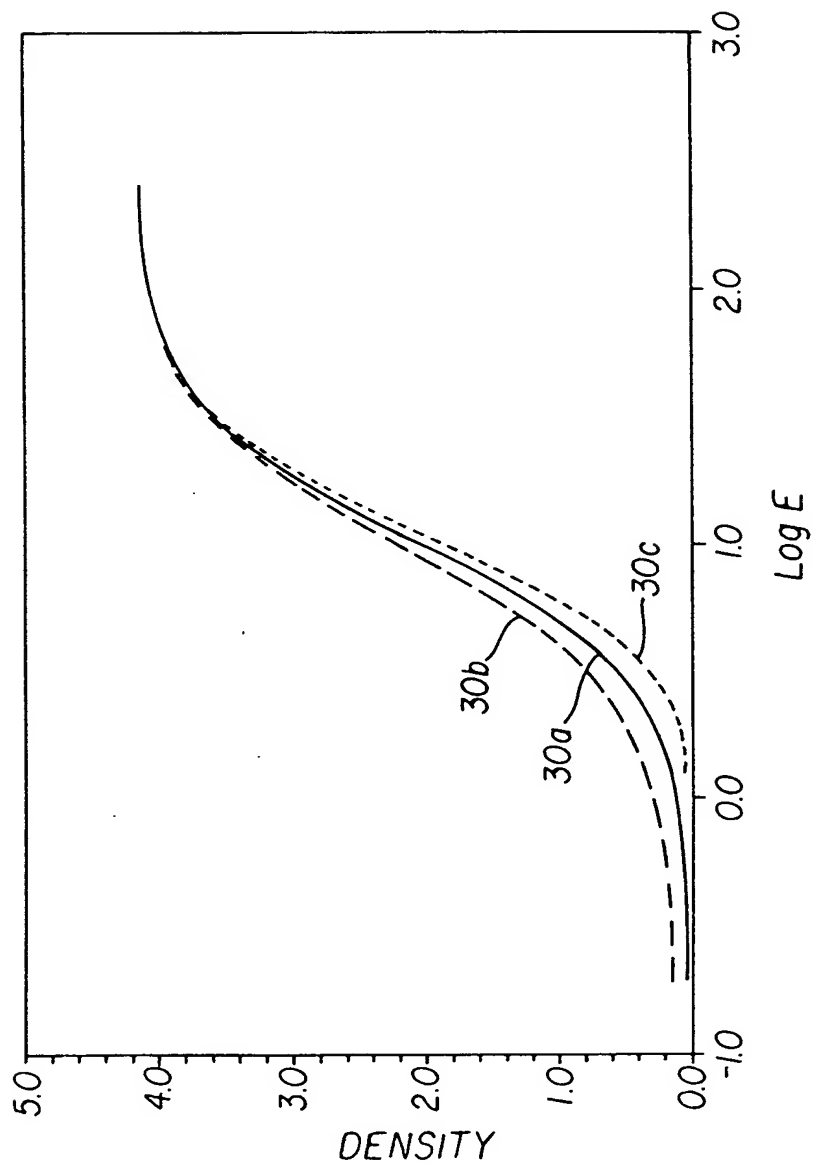


FIG. 4

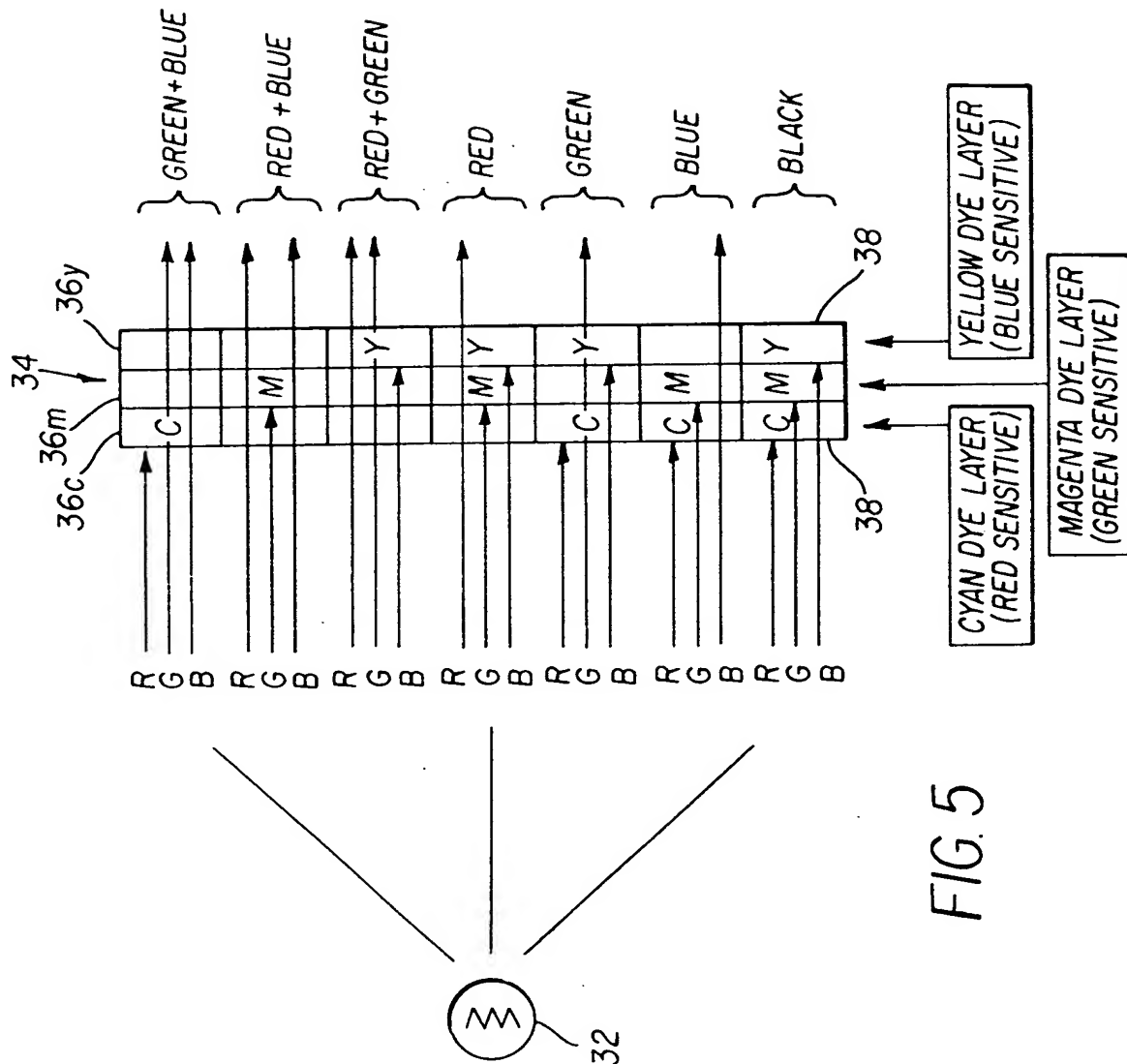


FIG. 5

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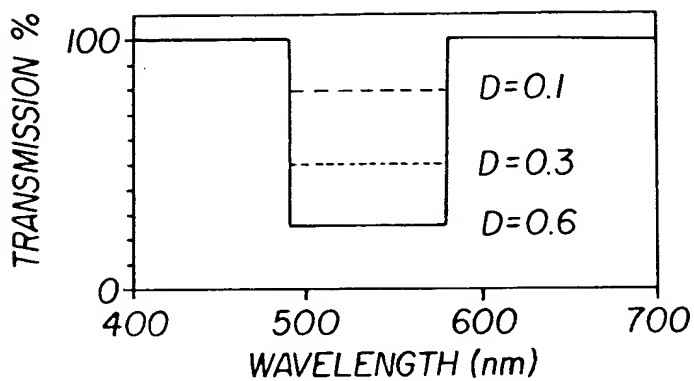


FIG. 6a

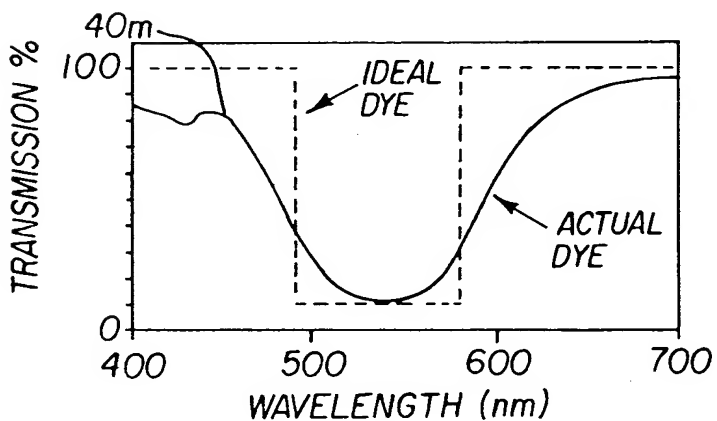


FIG. 6b

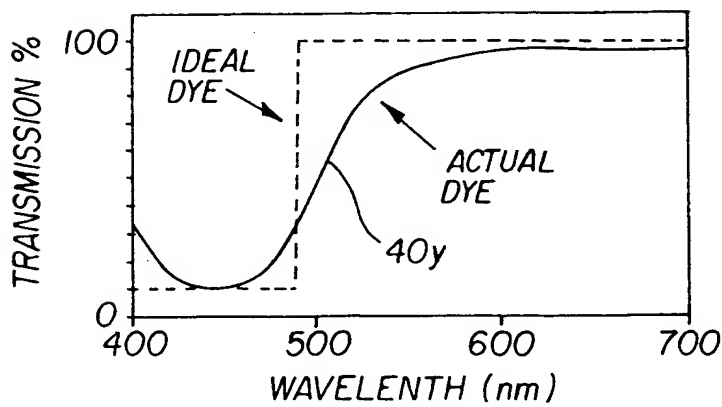
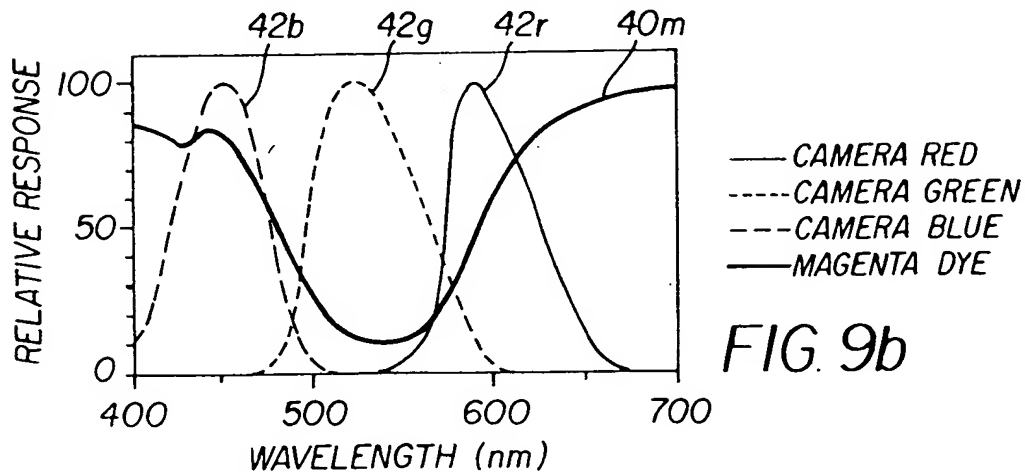
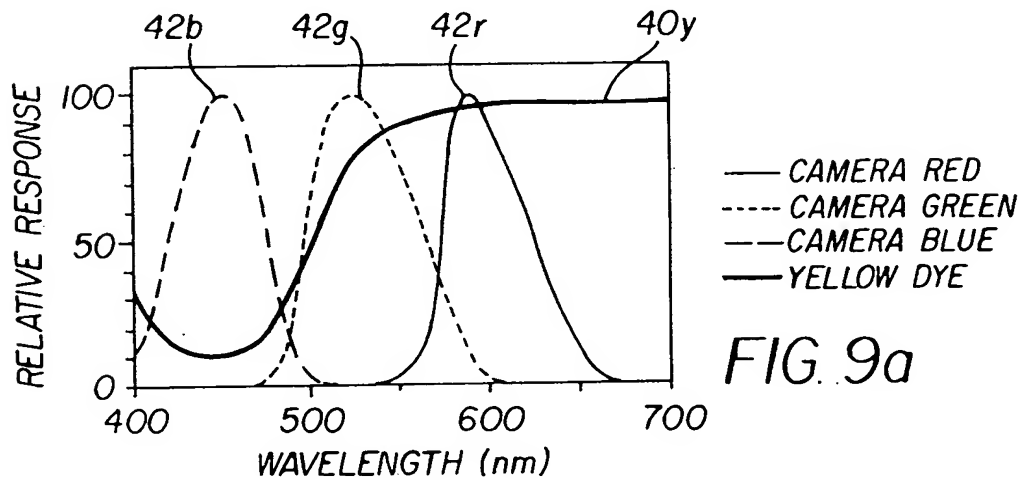
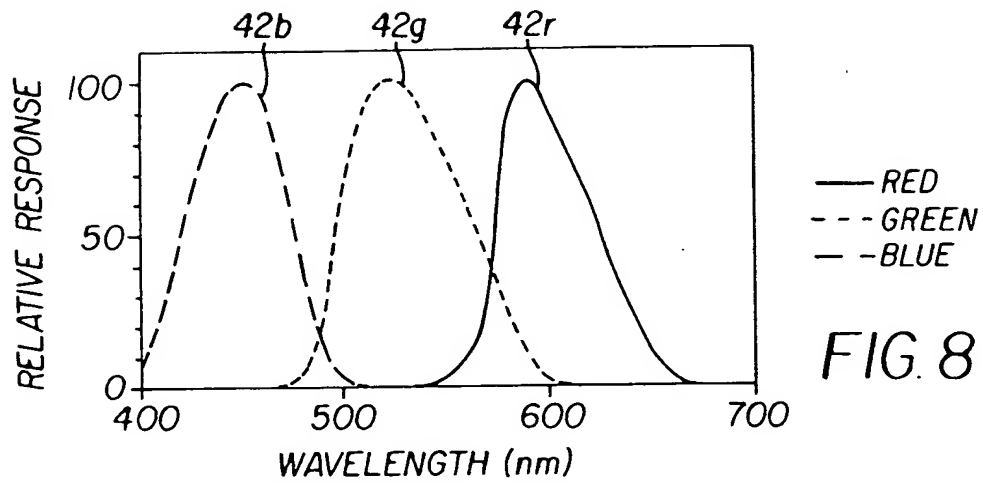


FIG. 7

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B	G	B	G	B	G	B
G	R	G	R	G	R	G
B	G	B	G	B	G	B
G	R	G	R	G	R	G
B	G	B	G	B	G	B

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FIG. 10

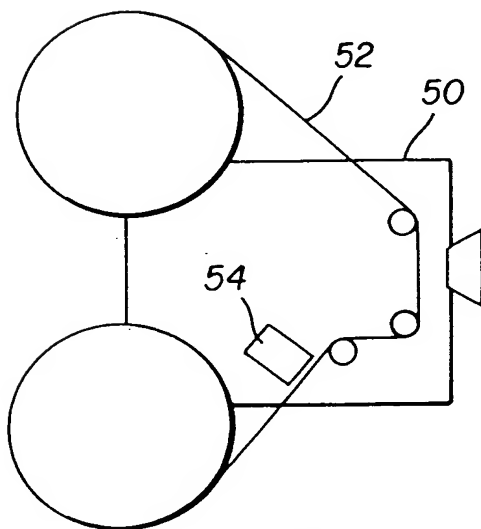


FIG. 11